

TLT-6 MEMS TILTSENSOR

Datasheet TLT-6



Description

The MEMS Tiltensor is designed to monitor vertical rotations of structures.

Mounted within the Stainless Steel housing are one or two (uniaxial or biaxial) MEMS sensors that deliver a large measuring range with high sensitivity and relative immunity from the effects of long cable lengths.

Each sensor incorporates an on-board microprocessor which performs an automatic temperature compensation of the tilt (g) data, delivering reliable, accurate and stable data.

The sensors are powered and the readings obtained by a Datalogger. The data can be directly imported into 'Argus' monitoring software, providing a near real time profile of displacement that is constantly updated and available to view from any PC or mobile device with an internet connection.

Features

- Accurate and precise measurements using MEMS sensors
- Available in uniaxial and biaxial versions
- Inbuilt temperature compensation
- Stainless Steel construction, waterproof to 2000kPa

Benefits

- Easy to automate using data acquisition systems and 'Argus' software
- Removes the need for manual monitoring
- Suitable for safety critical applications
- Low power consumption



Comprehensive information about this product and our full range is available at www.soil.co.uk
If you would like to speak with someone directly please call +44 (0)1825 765044 or email sales@soil.co.uk



Microelectromechanical Systems, or MEMS, is a technology that uses miniaturised mechanical and electromechanical elements that are made using the techniques of microfabrication. The physical dimensions of MEMS devices can vary from well below one micron all the way to several millimetres.

Our MEMS microsensor is a small discrete device that converts a measured mechanical signal, gravity (g) into a voltage signal.

Operation

Once the location for the MEMS Tiltensor has been established the position is marked out, ensuring that the sensor is correctly orientated towards the direction of movement.

The marked locations are drilled to depth and the 8mm shell anchors supplied with the Tiltensor are installed. Studding is screwed into the shell anchors, leaving a sufficient length to incorporate the bracket and the Tiltensor.

Once the studding is in place, the Tiltensor bracket is mounted on to the studding, ensuring there is an adequate space between the structure and the Tiltensor before securing in place using the M8 washers and nuts.

A spirit level is used to check that the Tiltensor is level in both directions, and then the nuts are securely tightened before the Tiltensor is finally wired into a datalogger.

The system can be fully automated using 'Argus' monitoring software, providing a near real time profile of displacement.

Applications

The MEMS Tiltensor monitors vertical rotations of structures.

Its most common use is to monitor settlement and heave of existing structures and tunnels caused by adjacent excavations or tunnelling works.

The sensor is especially useful where topographic measurements are precluded or where access is restricted.

Typical monitoring applications include:

- Brick and stone buildings
- Vertical rotation (heave and settlement) due to adjacent construction activities
- Bridges and dams
- Impounding and loading effects in short or long-term
- Differential levels
- Tunnels
- Monitoring vertical rotation and track formation

Associated products

For details on:

Catalogue code:

Datalogger

D1

View our full product range on www.soil.co.uk

THE TECHNICAL RATING FOR THIS PRODUCT:

As the correct installation of any monitoring sensor or system is vital to maximise performance and accuracy, Soil Instruments makes the following recommendations, for the skill level of the installation contractor.

ADDITIONAL SUPPORT

We offer installation and monitoring services to support this system. For more information please email : sales@soil.co.uk or call : **+44 (0) 1825 765044**

ADVANCED



ADVANCED



The installer is trained and experienced in the installation of this type of instrument or systems, and is ideally a specialist Instrumentation and Monitoring contractor.

INTERMEDIATE



The installer already has previous experience and/or training in the installation of this instrument or system.

BASIC



As a minimum the installer has read and fully comprehends the manual, and if possible has observed these instruments or systems being installed by others.

Specifications

Sensors

| | |
|----------------------------------|---|
| Calibrated Range | $\pm 3^\circ$ $\pm 5^\circ$ $\pm 10^\circ$ $\pm 15^\circ$ |
| Resolution ¹ | 0.008% full scale |
| Sensor accuracy | $\pm 0.05\%$ full scale |
| Operating temperature | -20 to +80°C |
| Repeatability | $\pm 0.01\%$ full scale |
| Minimum casing internal diameter | 56mm |
| Maximum casing internal diameter | 72mm |
| Weight (without cable) | 540g |
| Dimensions | 192mm x Ø32mm |
| Input voltage | 10-16VDC |
| Signal output at full range | $\pm 2.5\text{VDC}$ differential |
| Current consumption | 9mA (uniaxial) / 17mA (biaxial) |
| Ingress protection | IP68 to 200mH ₂ O (2000kPa) |
| Housing material | Stainless Steel |

¹Dependent on readout equipment

Ordering Information

MEMS Tiltensor - uniaxial

Includes mounting bracket

| | |
|-------------|---|
| TLT-6-U-3 | Vertical uniaxial ± 52.3 mm/metre (± 3 arc degrees) |
| TLT-6-U-5 | Vertical uniaxial ± 87.2 mm/metre (± 5 arc degrees) |
| TLT-6-U-10 | Vertical uniaxial ± 173.6 mm/metre (± 10 arc degrees) |
| TLT-6-U-15 | Vertical uniaxial ± 258.8 mm/metre (± 15 arc degrees) |
| CA-3.1-4-IC | Instrument cable 4 core, 7/0.20; screened, priced per metre, polyurethane jacket, for use with uniaxial sensors |

MEMS Tiltensor - biaxial

Includes mounting bracket

| | |
|-------------|---|
| TLT-6-B-3 | Vertical biaxial ± 52.3 mm/metre (± 3 arc degrees) |
| TLT-6-B-5 | Vertical biaxial ± 87.2 mm/metre (± 5 arc degrees) |
| TLT-6-B-10 | Vertical biaxial ± 173.6 mm/metre (± 10 arc degrees) |
| TLT-6-B-15 | Vertical biaxial ± 258.8 mm/metre (± 15 arc degrees) |
| CA-3.1-6-IC | Instrument cable, 6 core, 7/0.20; screened, priced per metre, polyurethane jacket, for use with biaxial sensors |

Manual

| | |
|---------|-----------------------------------|
| MAN-193 | MEMS Tiltensor (IPI Sensor Based) |
|---------|-----------------------------------|

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INSTRUMENTS



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